L Numbe	r Hits	Search Text	00	
1	1018		USPAT;	Time stamp
4			EPO; JPO; DERWENT; USOCR	2003/04/03 12:53
3	3	(((aluminum adj nitride) adj (substrate or layer)) and thickness and mil) and capacitor	USPAT; EPO; JPO; DERWENT;	2003/04/03 13:33
4	1	(aluminum adj nitride adj substrate) same thickness same mil	USOCR USPAT; EPO; JPO; DERWENT;	2003/04/03 12:58
5	641	(aluminum adj nitride adj substrate)	USOCR USPAT; EPO; JPO; DERWENT;	2003/04/03 12:58
6	24	((aluminum adj nitride adj substrate) ) and thickness and mil	USOCR USPAT; EPO; JPO; DERWENT;	2003/04/03 12:58
7	2	(((aluminum adj nitride adj substrate) ) and thickness and mil) and capacitor	USOCR USPAT; EPO; JPO; DERWENT;	2003/04/03 12:59
8	38	((aluminum adj nitride adj substrate) ) and capacitor	USOCR USPAT; EPO; JPO; DERWENT;	2003/04/03 13:30
9	11	("2585700"   "3247573"   "3753816"   "3947956"   "4176443"   "4546065"   "4591537"   "4649070"   "4659611"   "4770953"   "4882839").PN.	USOCR	2003/04/03 13:17
12 13	5 95	5184399.URPN. 257/700.ccls. and (aluminum adj nitride)	USPAT USPAT; EPO; JPO; DERWENT;	2003/04/03 13:18 2003/04/03 13:30
14	21	(257/700.ccls. and (aluminum adj nitride)) and capacitor	USOCR USPAT; EPO; JPO; DERWENT;	2003/04/03 13:33
15	534	((aluminum adj nitride) adj (substrate or layer)) and thickness	USOCR USPAT; EPO; JPO; DERWENT;	2003/04/03 13:33
16	3	(((aluminum adj nitride) adj (substrate or layer)) and thickness) and (decoupling adj capacitor)	USOCR USPAT; EPO; JPO; DERWENT; USOCR	2003/04/03 14:24
17	12	(("5123613") or ("5377072") or ("5791139") or ("6049973") or ("6137275") or ("6147678")).PN.	USPAT; EPO; JPO; DERWENT;	2003/04/03 13:36
18	13	("3268744"   "4167018"   "4914546"   "4929989"   "5049979"   "5055905"   "5083184"   "5095402"   "5140496"   "5187637"   "5281846"   "5311057"   "5313693").PN.	USOCR USPAT	2003/04/03 13:38
21 2		5377072.URPN. ((aluminum adj nitride) adj (substrate or layer)) and thickness and mil	USPAT USPAT; EPO; JPO; DERWENT; USOCR	2003/04/03 13:40 2003/04/03 13:44
22	0	361/763.ccls. and ((aluminum adj nitride) adj (substrate or layer))	USPAT; EPO; JPO; DERWENT; USOCR	2003/04/03 13:45

23	4	361/763.ccls. and (aluminum adj nitride)	USPAT; EPO; JPO;	2003/04/03 13:50
			DERWENT:	~
24	0057		USOCR	
24	3257	decoupling adj capacitor	USPAT;	2003/04/03 13:48
			EPO; JPO;	
			DERWENT;	
25			USOCR	
23	6		USPAT;	2003/04/03 13:48
1		(decoupling adj capacitor)	EPO; JPO;	
			DERWENT;	
26	41	(do counting a still a	USOCR	•
	4'	(decoupling adj capacitor) and (aluminum adj nitride)	USPAT;	2003/04/03 14:22
			EPO; JPO;	ļ
			DERWENT;	
27	29	((decoupling adi conseits a) - + ( + + + + + + + + + + + + + + + + +	USOCR	
	23	((decoupling adj capacitor) and (aluminum adj nitride))	USPAT;	2003/04/03 14:23
		and unchiess	EPO; JPO;	
			DERWENT;	
28	26947	ceramic adj substrate	USOCR	
		a stanto daj sabstrate	USPAT;	2003/04/03 13:55
ļ	Í		EPO; JPO;	
			DERWENT;	
29	1227	(ceramic adj substrate) and (aluminum adj nitride)	USOCR	
-		( aluminum auj munde)	USPAT;	2003/04/03 15:03
			EPO; JPO;	
			DERWENT; USOCR	
30	882	((ceramic adj substrate) and (aluminum adj nitride)) and	USPAT:	000010410044
1		thickness	,	2003/04/03 14:23
			EPO; JPO; DERWENT;	
			USOCR .	9,7
32	1	(((ceramic adj substrate) and (aluminum adj nitride)) and	USPAT;	2003/04/03 15:01
	1	(thickness near mil)) and (decoupling adj capacitor)	EPO; JPO;	2003/04/03 15:01
1			DERWENT;	
33	40		USOCR	
33	18	(((ceramic adj substrate) and (aluminum adj nitride)) and	USPAT;	2003/04/03 14:24
		thickness) and (decoupling adj capacitor)	EPO; JPO;	
	-00		DERWENT;	
34	40	5272590.URPN.	USOCR	
31	18		USPAT	2003/04/03 14:29
	10	((ceramic adj substrate) and (aluminum adj nitride)) and (thickness near mil)	USPAT;	2003/04/03 14:30
		(unckness near mil)	EPO; JPO;	
			DERWENT;	1
36	1	( (decoupling adj capacitor) adj (apparatus or assembly))	USOCR	
İ	1	and (aluminum adj nitride)	USPAT;	2003/04/03 15:05
		,	EPO; JPO;	
			DERWENT;	
37	1	( (decoupling adj capacitor) adj (apparatus or assembly))	USOCR	0000/04/00 :
		and (ceramic adj substrate)	USPAT;	2003/04/03 15:07
1		· · · · · · · · · · · · · · · · · · ·	EPO; JPO; DERWENT:	
			USOCR	
38	13	4734819.URPN.	USPAT	2003/04/02 45:02
39	2	("6441483").PN.	USPAT;	2003/04/03 15:06 2003/04/03 15:07
			EPO; JPO:	2000/04/03 15:07
			DERWENT:	
40			USOCR	
40	20	("4996587"   "5444296"   "5652463"   "5674785"	USPAT	2003/04/03 15:07
		5608878"   "5898224"   "5952611"   "5973403"		
		"5994166"   "5994773"   "6005778"   "6013948"		
		"6020629"   "6051878"   "6081023"   "6087717"		201
	1	"6181002"   "6262488"   "6265771"   "6316727"		
	1	"2001/0015485").PN.		ı

35	26	(decoupling adj capacitor) adj (apparatus or assembly)	11004=	
		(docoupling adj capacitor) adj (apparatus or assembly)	USPAT;	2003/04/03 15:15
			EPO; JPO;	1
			DERWENT;	
41	2	("5184399").PN.	USOCR	
7.	2	( 5164599 ).PN.	USPAT;	2003/04/03 15:12
			EPO; JPO;	
			DERWENT;	
42		(mana	USOCR	
42	11	("2585700"   "3247573"   "3753816"   "3947956"	USPAT	2003/04/03 15:12
		"4176443"   "4546065"   "4591537"   "4649070"		
1		"4659611"   "4770953"   "4882839").PN.		
45	5	5184399.URPN.	USPAT	2003/04/03 15:14
46	26	(decoupling adj capacitor) adj (apparatus or assembly	USPAT;	2003/04/03 15:14
	-	or assemblies)	EPO; JPO;	2003/04/03 15:24
			DERWENT;	
			USOCR	
47	1	( (decoupling adj capacitor) adj (apparatus or assembly))	USPAT;	2002/04/02 45 05
		and (ceramic adj substrate)	EPO; JPO;	2003/04/03 15:25
			DERWENT;	
48	53	361/306.2.ccls. and substrate	USOCR	
		To wood and substrate	USPAT;	2003/04/03 15:18
			EPO; JPO;	1
1			DERWENT;	
49	6	(361/306.2.ccls. and substrate) and (ALN or (aluminum	USOCR	
		adj nitride))	USPAT;	2003/04/03 15:19
	İ	daj minde))	EPO; JPO;	
			DERWENT;	
50	6	(361/306.2 colo and autotion to 1 (4)4	USOCR	
00	"	(361/306.2.ccls. and substrate) and (AIN or (aluminum adj nitride))	USPAT;	2003/04/03 15:25
		adj murde))	EPO; JPO;	
			DERWENT;	
51	3257	/ 10 10 10 11 11 11 11 11 11 11 11 11 11	USOCR	
31	3257	(decoupling adj capacitor)	USPAT;	2003/04/03 15:24
			EPO; JPO;	
1	]		DERWENT:	
52			USOCR	
52	96	( (decoupling adj capacitor)) and (ceramic adj substrate)	USPAT:	2003/04/03 15:25
		· , , , , , , , , , , , , , , , , , , ,	EPO; JPO;	2000/04/00 10:20
			DERWENT;	
		•	USOCR	
53	23	(( (decoupling adj capacitor)) and (ceramic adj	USPAT;	2003/04/03 15:25
	}	substrate)) and (AIN or (aluminum adj nitride))	EPO; JPO;	2000/04/03 13:25
	1	•	DERWENT;	
			USOCR	